

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No. 09/233,377
Filing Date January 18, 1999
Inventor Gurtej S. Sandhu et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Pham, Thanhha S.
Attorney's Docket No. MI22-1114
Title: Method of Forming a Refractory Metal Silicide



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated:

October 7, 2003

By:

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

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